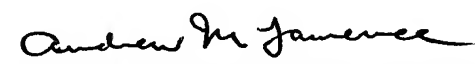




PATENT
Attorney Docket No. 29936/39455

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:)	
)	
Dong Ho Lee <i>et al.</i>)	I hereby certify that this paper is being
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)	1450, Alexandria, VA 22313-1450 on
For: Method of Manufacturing a)	this date:
Semiconductor Wafer)	
)	December 27, 2004
Group Art Unit: 2813)	
)	
Examiner: Chandra P. Chaudhari)	Andrew M. Lawrence, Reg. No. 46,130
)	Attorney for Applicants

AMENDMENT "A"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is in response to the official action dated August 25, 2004
(hereafter, "the official action").

The **Amendments to the Specification** section begins on page 2 of this paper.

The **Complete Listing of Claims** begins on page 3 of this paper.

The **Remarks** section begins on page 4 of this paper.